Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/677,341	FUJITA, SHIN	
Examiner	Art Unit	
David Y. Chung	2871	

SEARCHED					
Class	Subclass	Date	Examiner		
349	139	10/3/2005	DC		
349	143	3/6/2006	DC		
349	192	3/6/2006	DC		
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INTERFERENCE SEARCHED					
Subclass	Date	Examiner			
same	3/6/2006	DC			
	Subclass	Subclass Date			

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DATE	EXMR
10/3/2005	DC
3/6/2006	DC
	DATE